

**Notice of References Cited**

Application/Control No.

09/745,350

Applicant(s)/Patent Under  
Reexamination  
SABNIS ET AL.

Examiner

Nicole M Barreca

Art Unit

1756

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,277,750	08-2001	Pawlowski et al.	438/689
	B	US-5,654,376	08-1997	Knors et al.	525/327.4
	C	US-5,607,824	03-1997	Fahey et al.	430/510
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	JP 08-064492, English translation from USPTO, "Anti-Reflective Film and Pattern Formation Method which uses the same", 8/1996.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.